

Notice of References Cited	Application/Control No. 10/536,909		Applicant(s)/Patent Under Reexamination YASUDA ET AL.	
	Examiner Amanda C. Walke		Art Unit 1795	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,998,089	12-1999	Tajima et al.	430/270.1
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	U	Bellavia-Lund et al, Phosphous, Sulfur, and Silicon, VOL. 120&121, pp. 107-119 (1997).			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.